# Analogue Angular Rate Sensor High Performance MEMS Gyroscope





- Proven and Robust silicon MEMS VSG3Q<sup>MAX</sup> vibrating ring structure
- Four rate ranges available: ±25°/s, ±100°/s, ±200°/s and ±400°/s
- FOG like performance
- Low Bias Instability 0.12°/hr (100°/s)
- Excellent Angle Random Walk 0.017°/√hr
- Low noise 0.15% rms (50Hz bandwidth)
- Precision analogue output
- High shock and vibration rejection
- Wide range from -40°C to +85°C
- Temperature sensor output for precision thermal compensation
- MEMS frequency output for precision thermal compensation
- RoHS Compliant

## **Applications**

- Aerospace Applications
- Platform Stabilization
- Precision Surveying
- Maritime Guidance and Control
- Gyro-compassing and Heading Control
- Autonomous Vehicles and ROVs
- Rail Track monitoring

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- Robotics
- Drilling Equipment and Guidance
- Inertial Measurement Units



# 1 General Description

CRH02 provides the optimum solution for applications where bias instability, angle random walk and low noise are of critical importance.

At the heart of the CRH02 is Silicon Sensing's VSG3Q<sup>MAX</sup> vibrating ring MEMS sensor which is at the pinnacle of 15 years of design evolution and the latest off a line which has produced over 30 million high integrity MEMS inertial sensors. The VSG3Q<sup>MAX</sup> gyro sensor is combined with precision discrete electronics to achieve high stability and low noise, making the CRH02 a viable alternative to Fibre-Optic Gyro (FOG) and Dynamically Tuned Gyro (DTG).

An on board temperature sensor and the resonant frequency of the MEMS enables additional external conditioning to be applied to the CRH02 by the host, enhancing the performance even further.

Typical applications include downhole surveying, drilling equipment, precision platform stabilization, ship stabilisation, ship guidance and control, autonomous vehicles, high-end AHRS and other flight instruments.

Whatever your application, the unique and patented silicon ring technology gives advanced and stable performance over time and temperature, overcoming mount sensitivity problems associated with simple beam or tuning fork based sensors.

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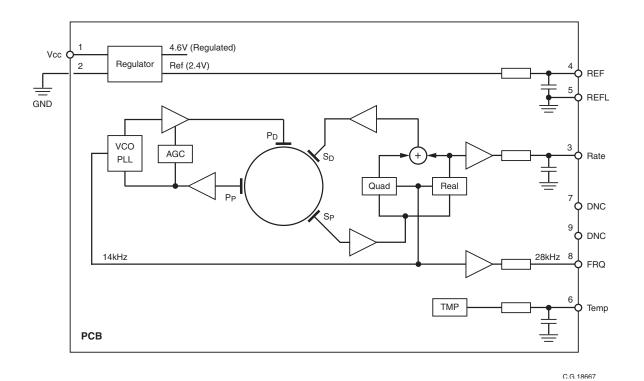


Figure 1.1 CRH02 Functional Block Diagram

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CRH02
MOE IN JAPAN

25.4

All dimensions in millimetres.

Figure 1.2 CRH02 Overall Dimensions

Figure 1.3 Mating Cable Assembly

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## 2 Ordering Information

Part Number	Rate Range
CRH02-025	±25°/s
CRH02-100	±100°/s
CRH02-200	±200°/s
CRH02-400	±400°/s

# 3 Specification

Unless otherwise specified the following specification values assume Vdd = 4.85 to 5.25V and an ambient temperature of +25°C. "Over temperature" refers to the temperature range -40°C to +85°C.

Parameter		Minimum	Typical	Maximum	Notes	
Characteristic	Characteristic					
	CRH02-025	±25°/s			-	
Poto Pongo	CRH02-100		±100°/s	_		
Rate Range	CRH02-200		±200°/s	_		
	CRH02-400	±400%			_	
	CRH02-025	79.6mV/°/s	80.0mV/°/s	80.4mV/°/s	_	
Scale Factor at 25°C	CRH02-100	19.9mV/°/s	20.0mV/°/s	20.1mV/°/s	_	
Scale Factor at 25°C	CRH02-200	9.95mV/°/s	10.0mV/°/s	10.05mV/°/s	_	
	CRH02-400	4.975mV/°/s	5.00mV/°/s	5.025mV/°/s	-	
Scale Factor Variation	CRH02-025 CRH02-100	-0.5%	±0.15%	+0.5%	_	
Over Temperature with respect to 25°C value	CRH02-200 CRH02-400	-0.5%	±0.3%	+0.5%	-	
Scale Factor Non-Linearity	CRH02-025 CRH02-100 CRH02-200	-0.05%	±0.02%	+0.05%	-	
	CRH02-400					
Bias at 25°C with respect to REF	CRH02	-10mV	_	+10mV	_	
Bias Over Temperature	CRH02-025	-0.2°/s	±0.1°/s	+0.2°/s		
	CRH02-100				_	
with respect to RT (25°C)	CRH02-200	0.05%	±0.15°/s	+0.25%s		
	CRH02-400	-0.25°/s			_	

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# **3 Specification Continued**

Parameter		Minimum	Typical	Maximum	Notes
Characteristic					
	CRH02-025	-			As measured using the Allan Variance method (Note 1)
Angular Random Walk	CRH02-100		0.017°/√hr		
	CRH02-200			_	
	CRH02-400				
	CRH02-025		0.12°/hr		As measured using the Allan Variance method
Dies Instability	CRH02-100				
Bias Instability	CRH02-200	_	0.1270f	_	(Note 2)
	CRH02-400				
	CRH02-025	_	0.15°/s rms	_	3~100Hz
Quiescent Noise	CRH02-100	_	0.20°/s rms	_	3~100Hz
Quiescent Noise	CRH02-200	_	0.20°/s rms	_	3~100Hz
	CRH02-400	_	0.15% rms	_	3~100Hz
	CRH02-025	_	50Hz	_	-
Bandwidth	CRH02-100	_	100Hz	_	-
Daridwidti	CRH02-200	_	100Hz	_	_
	CRH02-400	_	50Hz	_	_
Reference Output		2.380V	2.400V	2.420V	With respect to REFL output impedance 510ohm
Start Up Time		_	-	750ms	-
Physical					
Mass		_	45gram	_	_
Cross Axis Sensitivity		_	_	3%	_
Environmental					
Temperature (Operating)		-40°C	_	85°C	_
Temperature (Storage)		-40°C	_	100°C	-
Humidity		_	_	95%	Non-condensing
Linear Acceleration Sensiti	vity	_	0.02°/s/g	-	-
Shock (Operating)		_	_	95g x 6ms	½ sine
Shock (Powered Survival)		_	_	1,000g x 1ms	½ sine
Vibration Rectification Error		_	0.002°/s/g² rms	_	10-2,000Hz 10g rms
Vibration Induced Noise		_	0.01% rms/g² rms	-	10-2,000Hz 10g rms
MTTF		_	70,000hr	_	Calculation for continuous operation at +85°C
Electrical					
Supply Voltage (Functional)	)	4.75V	_	5.25V	_
Supply Voltage (Full Specif		4.85V	_	5.25V	_
Current Consumption		_	60mA	70mA	-

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#### 4 Absolute Maximum

Parameter	Minimum	Maximum				
Electrical						
Supply Voltage	_	6.0V				
ESD Protection	-	2kV HBM				
Temperature						
Operating	-40°C	85°C				
Storage	-40°C	100°C				
Humidity (Non-condensing)	-	95%				

## 5 Auxillary Output Signals

Parameter	Minimum	Typical	Maximum	Notes			
Frequency	Frequency						
Resonanting Ring Frequency	27kHz	28.0kHz	29kHz	Output impedance 1kohm			
Frequency Temperature Coefficient	-0.9Hz/°C	-0.80Hz/°C	-0.7Hz/°C	-			
Temperature	Temperature						
Temperature Sensor Offset at 0°C	-	-0.536V	-	With respect to REF output impedance 510ohm			
Temperature Sensor Offset at 25°C	-	-0.830V	-	With respect to REF output impedance 510ohm			
Temperature Sensor Scale Factor	-12.60mV/°C	-11.77mV/°C	-11.00mV/°C	Output impedance 510ohm			

- Note 1: The angle random walk is the value derived at the intercept of the ½ tangent on the Allan Variance plot and the 1 second correlation point (tau) divided by 60.
- Note 2: The bias instability is the value at the minimum part of the Allan Variance plot, usually between 10s and 100s.
- Note 3: The product must not be subjected to temperatures outside the recommended storage temperature range at any time.
- Note 4: CRH02 is a precision measurement instrument do not drop it onto a hard surface from a height exceeding 300mm.

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## **6 Typical Performance Characteristics**

This section shows the typical performance of CRH02, supplied with a 5.0V supply unless stated otherwise.

#### 6.1 Bias Characteristics

This section shows typical bias variation over temperature with, respect to the bias at +25°C.

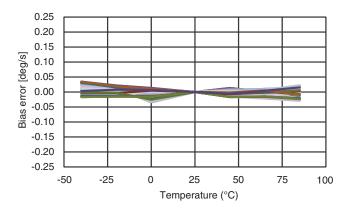


Figure 6.1 CRH02-025 Bias Variation over Temperature

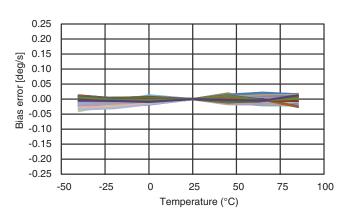


Figure 6.2 CRH02-100 Bias Variation over Temperature

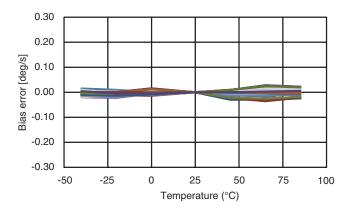


Figure 6.3 CRH02-200 Bias Variation over Temperature

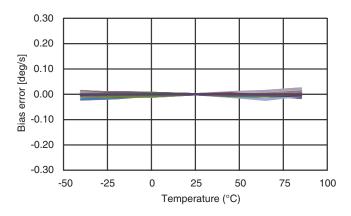


Figure 6.4 CRH02-400 Bias Variation over Temperature

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#### 6.2 Scale Factor Characteristics

This section shows the typical scale factor variation over temperature, with respect to the scale factor at +25°C.

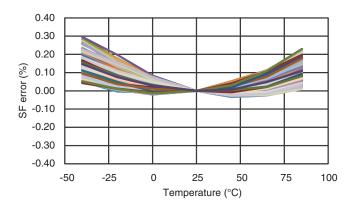


Figure 6.5 CRH02-025 Scale Factor Error over Temperature

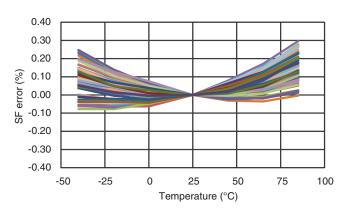


Figure 6.6 CRH02-100 Scale Factor Error over Temperature

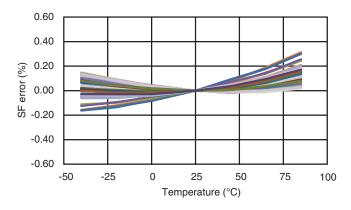


Figure 6.7 CRH02-200 Scale Factor Error over Temperature

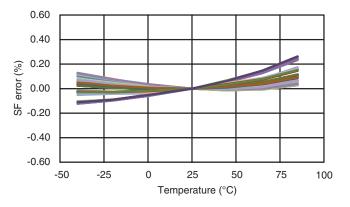


Figure 6.8 CRH02-400 Scale Factor Error over Temperature

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## 6.3 Non-Linearity Characteristics

This section shows the typical non-linearity error over temperature.

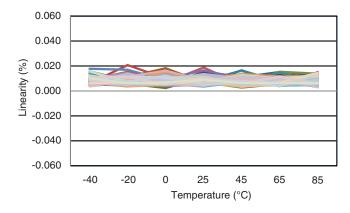


Figure 6.9 CRH02-025 Non-Linearity Error over Temperature

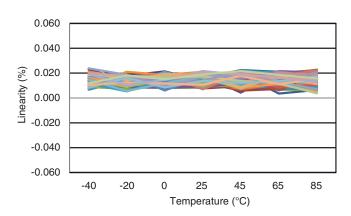


Figure 6.10 CRH02-100 Non-Linearity Error over Temperature

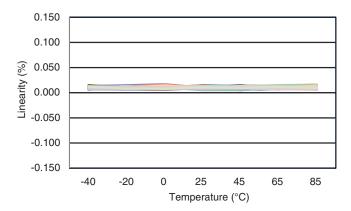


Figure 6.11 CRH02-200 Non-Linearity Error over Temperature

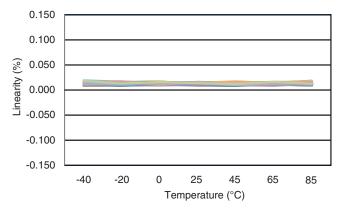


Figure 6.12 CRH02-400 Non-Linearity Error over Temperature

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## 6.4 Bias Variation with Supply Voltage

This section shows the typical Bias Variation with Supply Voltage at 25°C.

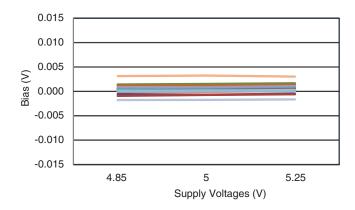


Figure 6.13 CRH02-025 Bias Variation with Supply Voltage

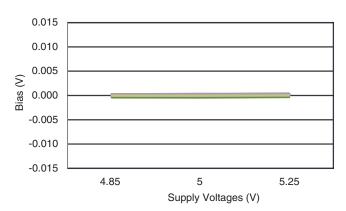


Figure 6.14 CRH02-100 Bias Variation with Supply Voltage

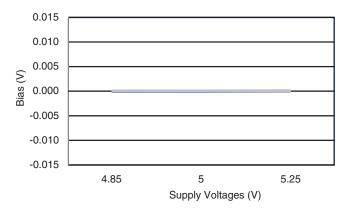


Figure 6.15 CRH02-200 Bias Variation with Supply Voltage

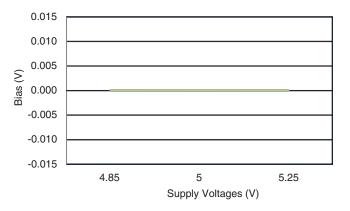


Figure 6.16 CRH02-400 Bias Variation with Supply Voltage

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# 6.5 Scale Factor Variation with Supply Voltage

This section shows the typical Scale Factor Variation with Supply Voltage at 25°C.

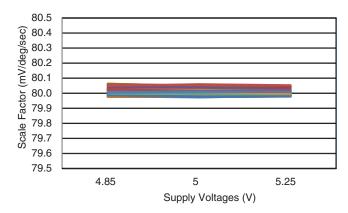


Figure 6.17 CRH02-025 Scale Factor Variation with Supply Voltage

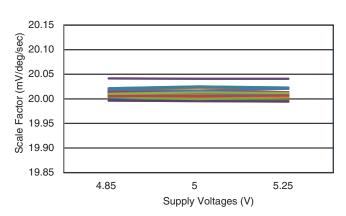


Figure 6.18 CRH02-100 Scale Factor Variation with Supply Voltage

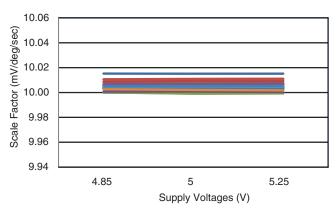


Figure 6.19 CRH02-200 Scale Factor Variation with Supply Voltage

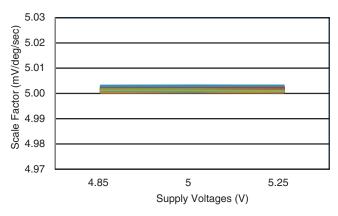


Figure 6.20 CRH02-400 Scale Factor Variation with Supply Voltage

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# 6.6 Current Consumption with Temperature

This section shows the typical Current Consumption over temperature.

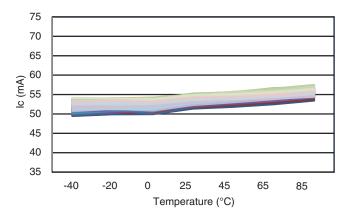


Figure 6.21 CRH02-025 Current Consumption over Temperature

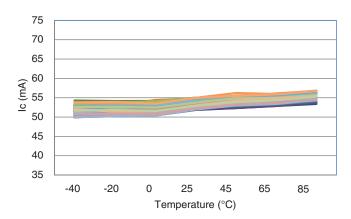


Figure 6.22 CRH02-100 Current Consumption over Temperature

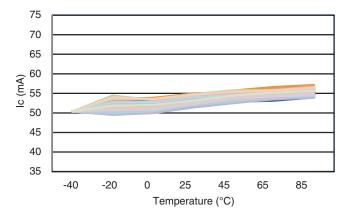


Figure 6.23 CRH02-200 Current Consumption over Temperature

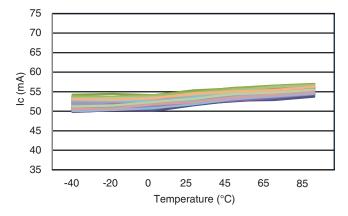


Figure 6.24 CRH02-400 Current Consumption over Temperature

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### 6.7 Allan Variance Current Consumption with Temperature

This section shows the typical Allan Variance graphs for the CRH02s at constant temperature.

Figure 6.25 shows a general Allan Variance graph as a guide for calculating Bias Instability and Angle Random Walk. The Angle Random Walk is calculated as follows:

- a. A line is drawn tangential to the Allan Variance graph at a -1/2 gradient (on a log-log plot).
- The line is extrapolated to intercept the 1 second correlation point (tau). The value at the intercept point is noted.
- c. The Angle Random Walk is this value, in units of degrees/hour, divided by 60. In the Figure 6.25, the line intercept the 1 second correlation time at 0.57°/h, giving an Angle Random Walk of 0.01°/√h.

The Bias Instability is value at the minimum part of the Allan Variance plot, usually between correlation times of 10s and 100s. In the Figure 6.25, the Bias Instability is approximately 0.05°/h.

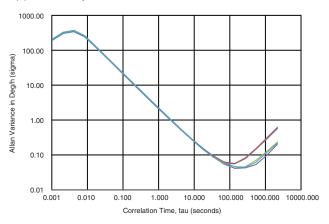


Figure 6.26 CRH02-025 Allan Variance

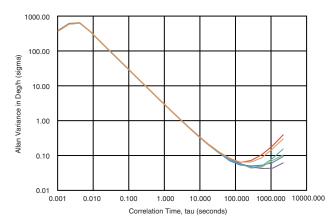


Figure 6.28 CRH02-200 Allan Variance

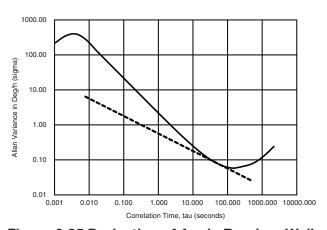


Figure 6.25 Derivation of Angle Random Walk and Bias Instability

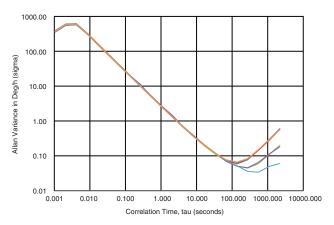


Figure 6.27 CRH02-100 Allan Variance

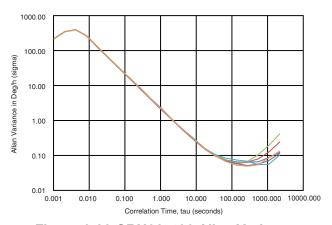


Figure 6.29 CRH02-400 Allan Variance

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#### 7 Interface

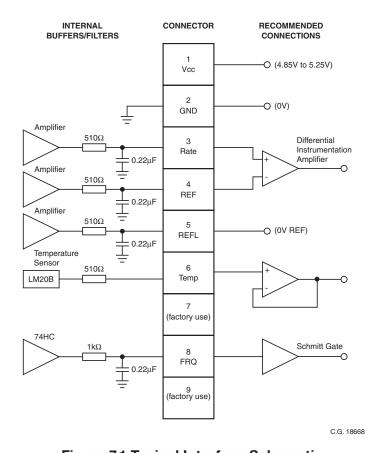


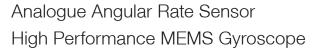
Figure 7.1 Typical Interface Schematic

Pin Number	Pin Name	Signal Direction (I/O)	Accessory Cable	Function	
1	Vcc	-	Red Power supply to Sensor (4.85V~5.25V)		
2	GND	-	Black	Power ground	
3	Rate	Output	White	Rate output with respect to REF	
4	REF	Output	Green	Reference voltage Datum for Rate, Temp	
5	REFL	Output	Grey	Reference Low voltage	
6	Temp	Output	Yellow	Temperature output with respect to REF	
7	DNC	-	-	Do Not Connect (factory use)	
8	FRQ	Output	Blue	Second Harmonic Resonating Ring Frequency output	
9	DNC	-	-	Do Not Connect (factory use)	

**Table 7.1 Connector Pin Identifications** 

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# 7.1 Supply Voltage

The CRH02 consists of angular rate sensors with non-ratiometric characteristics that are independent of the supplied voltage, provided the supplied voltage is within the operating voltage range.

The supply voltage, including ripple voltage and power supply noise, must be controlled so that it does not drop below 4.85V in order to maintain full performance.

### 7.2 Mating Cable Assembly

Each CRH02 is supplied with a single mating cable assembly (see Figure 1.3).

The cable assembly is Hirose Electric Co., Ltd. Part Number: DF13A-9S-1.25C.

### 7.3 Temperature Sensor

The temperature sensor uses a LM20B device, internally connected as shown in Figure 7.2.

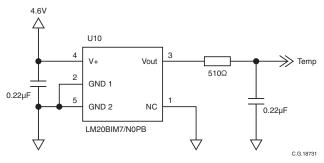


Figure 7.2 Temperature Sensor

The output at 0°C is typically +1.864V with respect to REFL. The temperature coefficient is typically -11.77 mV/°C.

The output can be measured with respect to REFL or can be put through a differential input instrumentation amplifier, referenced to the REF pin, in which case the offset at 0°C is typically -0.536V. At +25°C, the output is typically -0.830V with respect to REF. The temperature sensor is not intended for use as a thermometer, since they are not calibrated on the Celsius scale. They are intended only as a temperature reference for thermal compensation techniques.

#### 7.4 Rate and Ref Outputs

Both the Rate and the REF outputs are protected by a resistor before the output pins. The resistor value is 510 ohms.

It is important to take these resistor values into account when calculating the gains of external differential amplifiers. It is also recommended that the REF signal is buffered if it is used as a reference for more than one signal.

It is recommended that the Rate Output is differentially sensed using a precision instrumentation amplifier, referenced to the REF output. A reference Low (0V), REFL is also provided as a ground reference for external ADCS (see Figure 7.1).

The Offset of the instrumentation amplifier should be derived from the host stage (e.g. derived from the ADC REF Voltage) or from the signal ground if the following stage is an analogue stage.

### 7.5 Frequency Outputs

This is CMOS Digital (74HC series) compatible digital output at two times the frequency of the sensor head. It is provided to give an indication of the temperature of the MEMS sensor head. The nominal frequency is 28 KHz with a typical temperature coefficient of -0.8 Hz/°C.

The signal is protected with a 1Kohm resistor before being output from the CRH02. It is recommended that this signal is buffered with a CMOS Schmitt Gate such as 74HC12, or TC7S14F. The signal can be used to accurately measure the temperature of the MEMS structure.

An example of measuring the MEMS temperature is to use a precision crystal oscillator (operating at a very high frequency, for example 20, 40 or 60 MHz) to measure the frequency of the ring by measuring the time (oscillator clock cycles) to count to a defined number of ring cycles.

# 7.6 Interaction between Multiple Gyroscopes

The resonant frequency of the gyroscope is nominally 14kHz. If multiple gyroscopes are operated together, there is the possibility of interaction between them, causing a beat frequency to become apparent on their outputs.

Where optimum performance is required, it is recommended that each gyroscope is carefully isolated, both electrically and mechanically.

Electrical isolation can be achieved by using a separate low drop out linear power regulator for each gyroscope.

Mechanical isolation can be achieved by mounting the gyroscopes as far apart from each-other as possible or by the use of anti-vibration or compliant mounts.

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# Analogue Angular Rate Sensor High Performance MEMS Gyroscope



### 8 Glossary of Terms

**ADC** Analogue to Digital Converter

ARW Angular Random Walk

BW Bandwidth

С Celsius or Centigrade

DAC Digital to Analogue Converter

DPH Degrees Per Hour **DPS** 

**DRIE** Deep Reactive Ion Etch

**EMC** Electro-Magnetic Compatibility

Degrees Per Second

**ESD** Electro-Static Damage

Farads Hour

**HBM** Human Body Model

Hz Hertz, Cycle Per Second

Κ

**MEMS** Micro-Electro Mechanical Systems

mV Milli-Volts

**NEC** Not Electrically Connected

NL Scale Factor Non-Linearity

PD Primary Drive PP Primary Pick-Off

RC Resistor and Capacitor filter

Seconds SF Scale Factor

**SMT** Surface Mount Technology

SOG Silicon On Glass SD Secondary Drive SP Secondary Pick-Off To Be Announced T.B.A. T.B.D. To Be Described

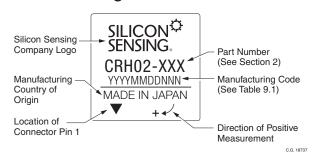
٧ Volts

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**VSG** Vibrating Structure Gyroscope

With Respect To w.r.t.

### 9 Part Markings



**Figure 9.1 Part Marking** 

Data	Code	Range
Manufacture Year	YYYY	0000 - 9999
Manufacture Month	MM	01 - 12
Manufacture Day	DD	01 - 31
Manufacture Number	NNN	001 - 999

**Table 9.1 Manufacturing Code** 

# 10 Silicon MEMS Ring Sensor (Gyro)

The silicon MEMS ring is 6mm diameter by 100µm thick, fabricated by Silicon Sensing Systems using a DRIE (Deep Reactive Ion Etch) bulk silicon process. The ring is supported in free-space by sixteen pairs of symmetrical legs which isolate the ring from the supporting structure on the outside of the ring.

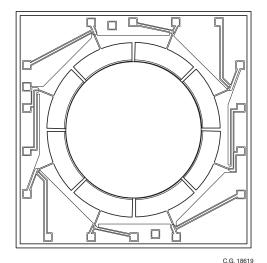


Figure 10.1 Silicon MEMS Ring

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# Analogue Angular Rate Sensor High Performance MEMS Gyroscope



The bulk silicon etch process and unique patented ring design enable close tolerance geometrical properties for precise balance and thermal stability and, unlike other MEMS gyros, there are no small gaps to create problems of interference and stiction. These features contribute significantly to CRH02's bias and scale factor stability over temperature, and vibration immunity. Another advantage of the design is its inherent immunity to acceleration induced rate error, or 'g-sensitivity'.

Pedestal Glass Can Base Support Glass Lower Pole

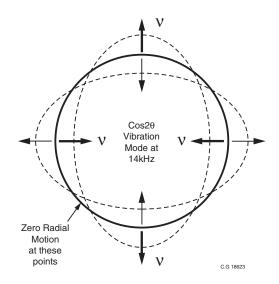
Figure 10.2 MEMS VSG3 Sensor

The ring is essentially divided into 8 sections with two conductive tracks in each section. These tracks enter and exit the ring on the supporting legs. The silicon ring is bonded to a glass pedestal which in turn is bonded to a glass support base. A magnet, with upper and lower poles, is used to create a strong and uniform magnetic field across the silicon ring. The complete assembly is mounted within a hermetic can.

The tracks along the top of the ring form two pairs of drive tracks and two pairs of pick-off tracks. Each section has two loops to improve drive and pick-off quality.

One pair of diametrically opposed tracking sections, known as the Primary Drive PD section, is used to excite the cos20 mode of vibration on the ring. This is achieved by passing current through the tracking, and because the tracks are within a magnetic field causes motion on the ring. Another pair of diametrically opposed tacking sections is known as the Primary Pick-off PP section is used to measure the amplitude and phase of the vibration on the ring. The Primary Pick-off sections are in the sections 90° to those of the Primary Drive sections. The drive amplitude and frequency is controlled by a precision closed loop electronic architecture with the frequency controlled by a Phase Locked Loop (PLL), operating with a

Voltage Controlled Oscillator (VCO), and amplitude controlled with an Automatic Gain Control (AGC) system. The primary loop therefore establishes the vibration on the ring and the closed loop electronics is used to track frequency changes and maintain the optimal amplitude of vibration over temperature and life. The loop is designed to operate at about 14kHz.



**Figure 10.3 Primary Vibration Mode** 

Having established the  $\cos 2\theta$  mode of vibration on the ring, the ring becomes a Coriolis Vibrating Structure Gyroscope. When the gyroscope is rotated about its sense axis the Coriolis force acts tangentially on the ring, causing motions at 45° displaced from the primary mode of vibration. The amount of motion at this point is directly proportional to the rate of turn applied to the gyroscope. One pair of diametrically opposed tracking sections, known as the Secondary Pick-off SP section, is used to sense the level of this vibration. This is used in a secondary rate nulling loop to apply a signal to another pair of secondary sections, known as the Secondary Drive SD. The current applied to the Secondary Drive to null the secondary mode of vibration is a very accurate measure of the applied angular rate. All of these signals occur at the resonant frequency of the ring. The Secondary Drive signal is demodulated to baseband to give a voltage output directly proportional to the applied rate in free space.

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# Analogue Angular Rate Sensor High Performance MEMS Gyroscope

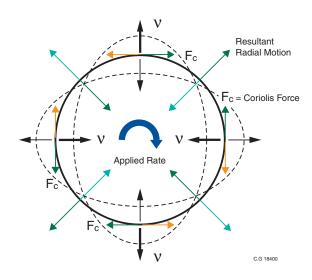


Figure 10.4 Secondary Vibration Mode

The closed loop architecture on both the primary and secondary loops results in excellent bias, scale factor and non-linearity control over a wide range of operating environments and life. The dual loop design, introduced into this new Sensor Head design, coupled with improved geometric symmetry results in excellent performance over temperature and life. The discrete electronics employed in CRH02, ensures that performance is not compromised.

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